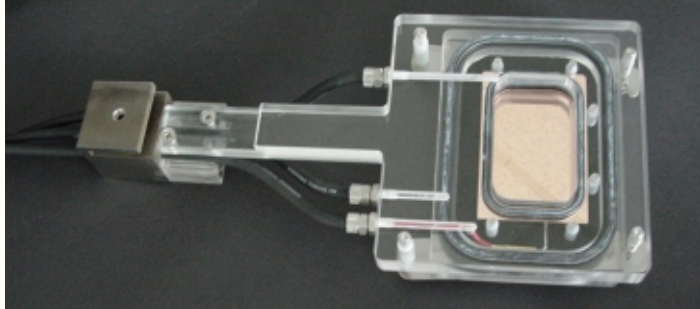


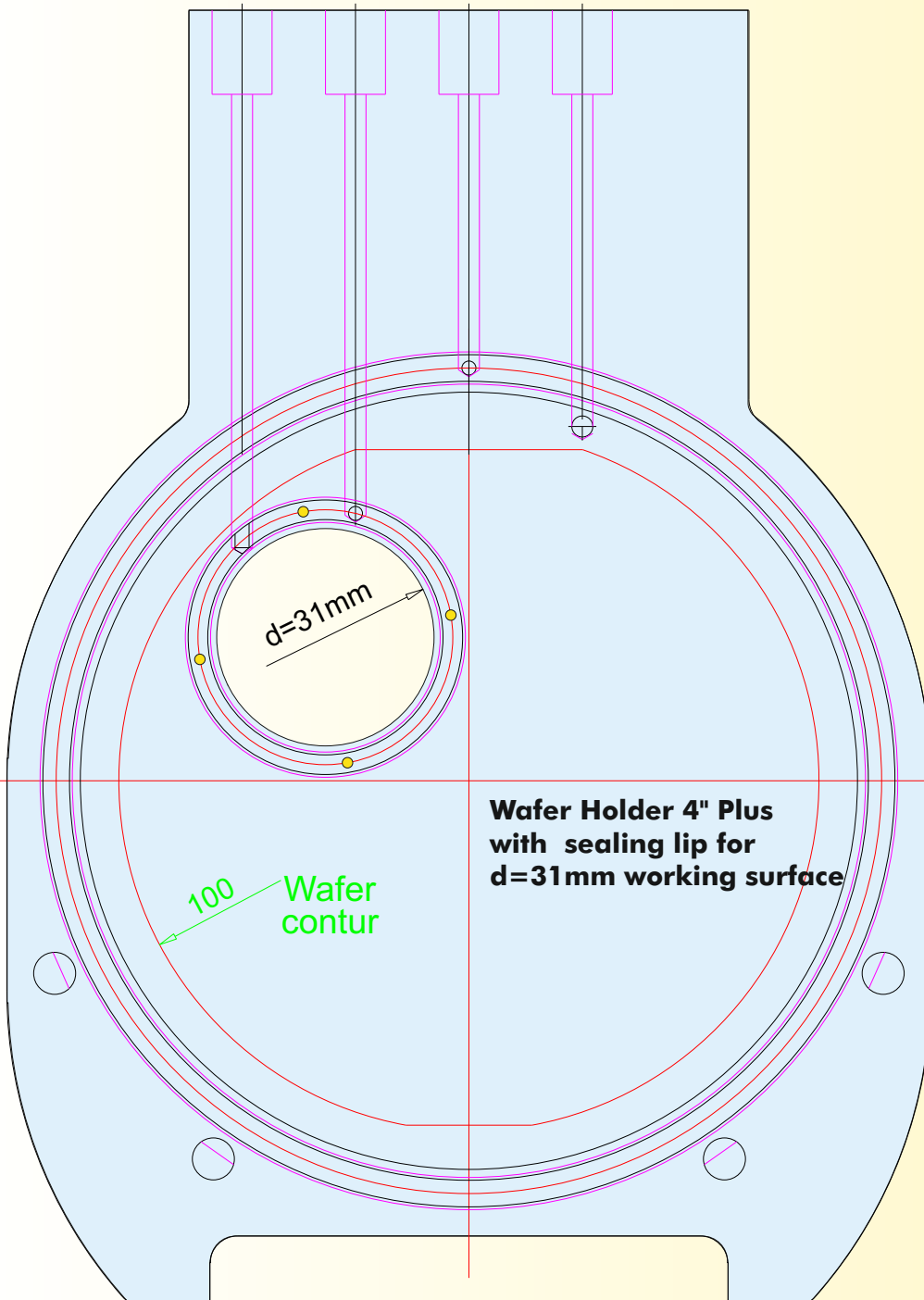
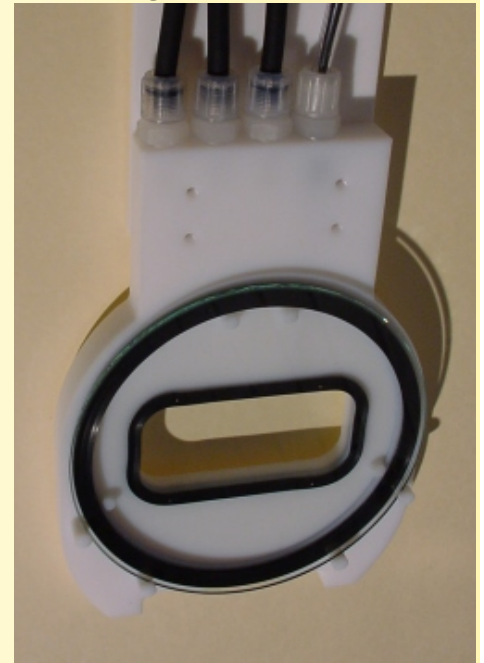
patented  
**VACUUM-HOLDER**

**PLUS PART (dimensions)**

**Substrate 82 x 52 mm**



**4" Plus with sealing lip  
for working surface 77 x 37 mm**



**Wafer Holder 4" Plus  
with sealing lip for  
 $d=31\text{mm}$  working surface**